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DATE: February 15, 2006
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FROM: Keith M. Tackett
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ORIGINAL TO FOLLOW? ☐ YES ☒ NO

RESPONSE TO OFFICE ACTION DATED NOVEMBER 15, 2005

TITLE: Method for Controlling Accuracy and Repeatability of an Etch Process
U.S. SERIAL NO.: 10/690,318
FILING DATE: October 21, 2003
INVENTOR: Mui, et al.
EXAMINER: Eric B. Chen
GROUP ART UNIT: 1765
CONFIRMATION NO.: 4521

CONFIDENTIALITY NOTE

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